

## APPLICATION DATA SHEET

### APPLICATION INFORMATION

Application Type:: REGULAR  
Subject Matter:: UTILITY  
CD-ROM or CD-R?: NONE  
Title:: POLYGON-TYPE SEMICONDUCTOR  
DETECTOR FOR USE IN HIGH-SPEED  
X-RAY CT, AND MANUFACTURING  
METHOD THEREFOR  
Attorney Docket Number:: 218866US2  
Total Drawing Sheets:: 1

### INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR  
Primary Citizenship Country:: Japan  
Status:: FULL CAPACITY  
Given Name:: Masaki  
Family Name:: MISAWA  
City of Residence:: Ibaraki  
Country of Residence:: Japan  
Street of Mailing Address:: 4-407-106 Matsushiro, Tsukuba  
City of Mailing Address:: Ibaraki  
Country of Mailing Address:: Japan  
Postal or Zip Code of Mailing Address:: 305-0035

### CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

### REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

### FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2001-023141	Japan	01/31/01	YES

### ASSIGNMENT INFORMATION

Assignee Name:: National Inst. of Advanced Ind. Science  
and Tech.  
Street of Mailing Address:: 3-1, Kasumigaseki 1-chome, Chiyoda-ku

City of Mailing Address::  
Country of Mailing Address::

Tokyo  
Japan

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